

FORM PTO-1449	Atty. Docket No.: 1100.1138101 (H16-17400)	Serial No.: 10/007,288
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Wood et al.	
	Filing Date: December 3, 2001	Group Art: 1745

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
	3,577,037	5/1971	Di Pietro			
	3,973,146	8/1976	Arnold et al.			
	4,400,870	8/1983	Islam			
	4,122,479	10/1978	Sugawara et al.			
	4,369,458	1/1983	Thomas et al.			
	4,555,720	11/1985	Redhead			
	4,582,210	4/1986	Morimoto et al.			
	4,701,424	10/1987	Mikkor			
	4,766,316	8/1988	Jungkman			
	4,784,970	11/1988	Solomon			
	4,821,997	4/1989	Zdeblick			
	4,833,102	5/1989	Byrne et al.s			
	4,897,508	1/1990	Mahulikar et al.			
	5,006,711	4/1991	Hanashima et al.			
	5,021,663	1/1997	Hornbeck			
	5,220,838	6/1993	Fung et al.			
	5,264,693	11/1993	Shimabukuro et al.			
	5,318,666	6/1994	Eklind et al.			
	5,366,587	11/1994	Ueda et al.			
	5,397,897	3/1995	Komatsu et al.			
	5,420,419	5/1995	Wood			
	5,521,123	5/1996	Komatsu et al.			
	5,528,452	6/1996	Ko			
	5,581,631	12/1998	Borden et al.			
	5,585,311	12/1996	Ko			

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	5,729,019	3/1998	Krafthefer et al.			
	5,736,430	4/1998	Seefeldt et al.			
	5,865,417	2/1999	Harris et al.			
	5,895,233	4/1999	Higashi et al.			
	6,036,872	3/2000	Wood et al.			
	6,359,333	3/2002	Wood et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation Yes No
	2121598	12/1983	GB	
	0453372	10/1991	EP	
	0736972	10/1996	EP	

OTHER ART (Including Author, Title, Date, Permanent Pages, Etc.)

	Barth, Philip W., "Silicon Fusion Bonding for Fabrication of Sensors, Actuators and Microstructures", Sensors and Actuators, A21-A23, (1990) pages 919-926.
	Bauer D. et al., "Design and Fabrication of a Thermal Infrared Emitter", Sensors and Actuators A., vol. 55, No. 1, July 15, 1996, pages 57-63.
	Cabuz, C., et al., "Fabrication and packaging of a resonant infrared sensor integrated in silicon", Sensors and Actuators A, 43, May 1994, pages 92-99.
	Henmi, H., et al., "Vacuum packaging for microsensors by glass-silicon anodic bonding", Sensors and Actuators A, 43, May 1994, pages 243-248.
	Kniffen M.L. et al., "Packaging for Silicon Micromachined Accelerometers", International Journal of Microcircuits and Electronic Packaging, vol. 19, No. 1, January 1, 1996, pages 75-86.
	Ko, Wen Hsiung, et al., "Development of a Miniature Pressure Transducer for Biomedical Applications", IEEE Transactions on Electron Devices, Vol. ED-26, No. 12, December 1979, pages 1896-1905.

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Mori T. et al., "Vacuum-encapsulated Thermistor bolometer Type Miniature Infrared Sensor".
Proceeding of the Workshop on Micro Electro Mehanica Systems (MEM, IOSO, January 25-28,
1994, No. Workshop 7, January 25, 1994, pages 257-262, Institute of Electrical and Electronics
Engineers.

Huang et al., "n-p-n Silicon Lateral Phototransistors for Hybrid Integrated Optical Circuits", IEEE
vol. ED-33. No. 4, April 1986, pages 433-441.

Reichl H., "Packaging and Interconnection of Sensors", Sensors and Actuators A, 25 27 (1991),
pages 63-71.

Senturia Stephen D., et al., "Microsensor Packaging and System Partitioning", Sensors and
Actuators, 15 (1988), pages 221-234.

Tilmans, Harrie A.C., et al., "Micro resonant force gauges", Sensors and Actuator A. 30 (1992)
pages 35-53.

Wolffenbuttel R.F., et al., "Low-temperature silicon wafer-to-wafer bonding using gold at eutectic
temperature", Sensors and Actuators A, 43, May 1994, pages 223-229.

EXAMINER:

DATE CONSIDERED:

3/21/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through
citation if not in conformance and not considered. Include copy of this form with next communication to applicant.